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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

LI et al

Serial No. 10/535,420

Atty. Ref.: 36-1899

Filed: May 19, 2005

TC/A.U.: 2611

Examiner: Unknown

For: METHOD AND SYSTEM FOR ESTIMATING GLOBAL MOTION IN
VIDEO SEQUENCES

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June 16, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

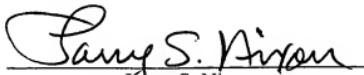
Further to the Information Disclosure Statement filed October 13, 2005, the remainder of the missing documents from the listed attached to the Information Disclosure Statement have now been obtained and are attached together with a further PTO-1449.

Consideration of each reference and return of an initialed copy of the attached form signifying same is requested.

Respectfully submitted,

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Sheet 1 of

**INFORMATION DISCLOSURE
CITATION**

ATTY. DOCKET NO.

SERIAL NO.

36-1899

10/535,420

APPLICANT

FILING DATE

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TC/A.U.

2611

(Use several sheets if necessary)

JUN 16 2006

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

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| /J.P./ | Meer et al, "Robust Regression Methods for Computer Vision: A Review", International Journal of Computer Vision, 6(1):59-70, 1991 |
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| /J.P./ | Meng et al, "CVEPS: A Compressed Video Editing and Parsing System", In ACM MULTIMEDIA, 1996 |
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/James Pontius/

Date Considered

06/22/2009

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /J.P./